

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Won-Sang SONG, et al.

Serial No.

Filed: April 14, 2004

[Division of Serial No. 09/949,853, filed September 12, 2001]

For: SEMICONDUCTOR DEVICE HAVING A METAL
SILICIDE LAYER AND METHOD FOR
MANUFACTURING THE SAME

CONFIRMATION
CLAIM FOR CONVENTION PRIORITY

Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

The benefit of the filing date of the following prior foreign application filed in the following foreign country is hereby requested, and the right of priority provided in 35 U.S.C. §119 is hereby claimed:

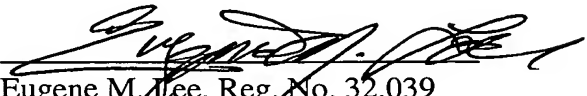
Application No. 2000-55769 - filed 22 September 2000 - Republic of Korea

In support of this claim, a certified copy of said original foreign application was filed in parent application Serial No. 09/949,853 on September 12, 2001.

^ Acknowledgment of applicant's claim for priority and receipt of the certified priority document is solicited.

Respectfully submitted,

Date: April 14, 2004


Eugene M. Lee, Reg. No. 32,039
Richard A. Sterba, Reg. No. 43,162

LEE & STERBA, P.C.
1101 WILSON BOULEVARD, SUITE 2000
ARLINGTON, VA 22209
703.525.0978 TEL
703.525.4265 FAX